

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/698,422	KATO ET AL.	
Examiner	Art Unit	

Kim-Kwok CHU

2627

	SEARCHED				
Class	Subclass	Date	Examiner		
369	59.25	9/25/2006	кс		
369	275.3	9/25/2006	кс		
369	275.4	9/25/2006	kc		
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
≰ Interference Search Updated		9/25/2006	kc

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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	9/25/2006			